



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Mazumder et al.

Serial No.: 09/916,566

Group No.: 2125

Filed: July 27, 2001

Examiner: E. Frank

For: DIRECT METAL DEPOSITION APPARATUS UTILIZING RAPID-RESPONSE DIODE  
LASER SOURCE

**AMENDMENT AND REPLY TO FINAL REJECTION**

Mail Stop AF  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed December 17, 2003, please amend the above-referenced application as follows: